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Signature

3-10-2000



PATENT APPLICATION
DOCKET NO. 042390.P6604

5/A
PS
3/23/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kevin J. Lee

)
)
)Group Art
)Unit 1741

Serial No.:

09/223,472

Filed:

December 30, 1998

ELECTROPLATING CELL
BASED UPON ROTATIONAL
PLATING SOLUTION FLOW

Examiner:

Christopher Keehan

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AMENDMENT "A" AND REPLY UNDER 37 C.F.R. §1.111

Honorable Commissioner of
Patents and Trademarks
Washington, D. C. 20231

Sir:

In response to the Office Action mailed December 7, 1999 (the "Office Action"),
the Applicants submit this amendment and reply.

03/15/2000 AIBRAHIM 00000115 09223472

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